

FORM PTO-1449

Docket Number (Optional)

Application Number

YOR9200010217US1

10/052,591

Applicant

Furman et al.

Filing Date

January 18, 2002

Group Art Unit

Not yet assigned

INFORMATION DISCLOSURE CITATION  
IN AN APPLICATION

APR 23 2002

(Use several sheets if necessary)

## U. S. PATENT DOCUMENTS

| EXAMINER<br>INITIAL | DOCUMENT<br>NUMBER | DATE    | NAME            | CLASS | SUBCLASS | FILING DATE IF<br>APPROPRIATE |
|---------------------|--------------------|---------|-----------------|-------|----------|-------------------------------|
| KS                  | 6,339,024          | 1/15/02 | Petrarca et al. | 438   | 686      |                               |
| KS                  | 6,344,125          | 2/5/02  | Locke et al.    | 205   | 118      |                               |
| KS                  | 6,368,484          | 4/9/02  | Volant et al.   | 205   | 220      |                               |
|                     |                    |         |                 |       |          |                               |
|                     |                    |         |                 |       |          |                               |
|                     |                    |         |                 |       |          |                               |
|                     |                    |         |                 |       |          |                               |
|                     |                    |         |                 |       |          |                               |
|                     |                    |         |                 |       |          |                               |
|                     |                    |         |                 |       |          |                               |
|                     |                    |         |                 |       |          |                               |
|                     |                    |         |                 |       |          |                               |
|                     |                    |         |                 |       |          |                               |
|                     |                    |         |                 |       |          |                               |
|                     |                    |         |                 |       |          |                               |

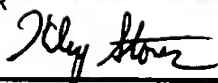
## FOREIGN PATENT DOCUMENTS

|  | DOCUMENT<br>NUMBER | DATE | COUNTRY | CLASS | SUBCLASS | Translation |    |
|--|--------------------|------|---------|-------|----------|-------------|----|
|  |                    |      |         |       |          | YES         | NO |
|  |                    |      |         |       |          |             |    |
|  |                    |      |         |       |          |             |    |
|  |                    |      |         |       |          |             |    |
|  |                    |      |         |       |          |             |    |
|  |                    |      |         |       |          |             |    |
|  |                    |      |         |       |          |             |    |
|  |                    |      |         |       |          |             |    |

## OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.)

|    |                                                                                                                                                                                                                           |
|----|---------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|
| KS | Richard Volant, Kevin Petrarca, Peter Locke, James A. Tornello and Donald F. Canaperi, Title: "Replated Metal Structures for Semiconductor Devices", U.S. Patent application Serial No. 09/657,469, filed on May 9, 2000. |
|    |                                                                                                                                                                                                                           |
|    |                                                                                                                                                                                                                           |
|    |                                                                                                                                                                                                                           |

EXAMINER



DATE CONSIDERED

8-18-03

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.